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**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q79097

Makoto MIYAZAWA

Appln. No.: 10/779,867

Group Art Unit: 3723

Confirmation No.: 6212

Examiner: Dung V. NGUYEN

Filed: February 18, 2004

For: ASPHERIC-SURFACE PROCESSING METHOD AND ASPHERIC-SURFACE  
FORMING METHOD

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 6, 2005, please amend the above-identified application as follows on the accompanying pages.

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